## In the Drawings

The attached replacement sheet replaces original Figure 5.



## METHOD FOR CONTROLLING AND MONITORING A CHEMICAL MECHANICAL

POLISHING PROCESS
Application No. 10/054,962
Inventor: Chun-Lien SU
Replacement Sheet

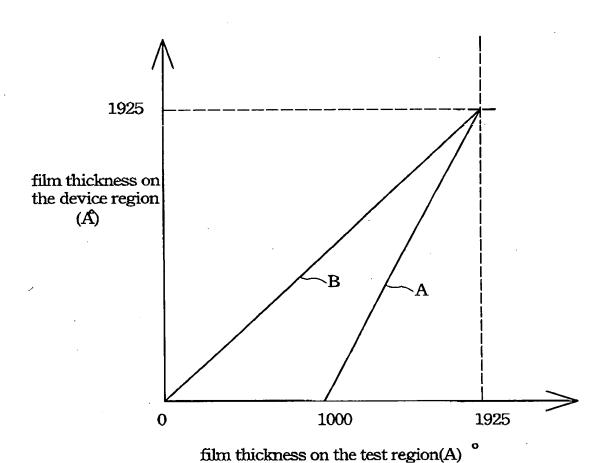


Fig. 5